Search Notes			

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/714,100	SEKIZAWA, HIROAKI	
Examiner	Art Unit	
Gabriel L. Chu	2114	

SEARCHED				
Class	Subclass	Date	Examiner	
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
Copril Ray	6/7	nc
IN/con	6/6	πe
714/46,57,399/8 and antral retwork	6/13	TE
Text Search	6114	πe